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PTO/SB/21 (09-04)

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PTO TRANSMITTAL FORM JAN 28 2005 (to be used for all correspondence after initial filing)	Application Number	10/815,994	
	Filing Date	March 31, 2004	
	First Named Inventor	Chung J. Lee	
	Art Unit	2827	
	Examiner Name		
Total Number of Pages in This Submission	9+	Attorney Docket Number	DSI 303

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Firm Name	Alleman Hall McCoy Russell & Tuttle LLP		
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Date	January 26, 2005	Reg. No.	43,653

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Date: January 26, 2005

CHUNG J. LEE and ATUL KUMAR

Serial No. : 10/815,994

Group Art Unit 2827

Filed : March 31, 2004

For : SINGLE AND DUAL DAMASCENE TECHNIQUES
UTILIZING COMPOSITE POLYMER DIELECTRIC FILM

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Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.56, 1.97, and 1.98

Applicants are submitting this Supplemental Information Disclosure Statement pursuant to 37 C.F.R. §§ 1.56, 1.97, and 1.98 to disclose to the U.S. Patent and Trademark Office the patents, publications, applications, and/or other references listed on the enclosed, completed PTO-1449 form(s). The filing of this Supplemental Information Disclosure Statement should not be construed as a representation that a search has been made or as an admission that the listed references are prior art for this application. Applicants respectfully request that the listed references be expressly considered during prosecution of the application, and that the references be made of record therein and appear among the "references cited" on any patents issuing therefrom.

CONTENT OF DISCLOSURE

This Supplemental Information Disclosure Statement includes (1) six pages of PTO-1449 forms, and (2) a legible copy of each foreign and non-patent reference, if any, listed on the form(s). However, because this application was filed on or after July 1, 2003, no copies of U.S. patents or published U.S. patent applications are included.

TIMING OF DISCLOSURE / FEE INFORMATION

This Supplemental Information Disclosure Statement is being filed, to the best of the undersigned's knowledge, either (1) before the mailing of a first Office action on the merits, or (2) before the mailing of a first Office action after the filing of a request for continued examination under 37 C.F.R. § 1.114. Therefore, in accordance with 37 C.F.R. § 1.97(b), no fee or statement under 37 C.F.R. § 1.97(e) is required.

Please contact the undersigned with any questions or comments regarding this Supplemental Information Disclosure Statement.

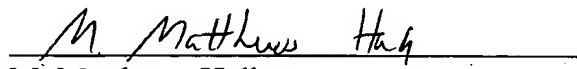
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Renee Knight

Respectfully submitted,

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FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN TRADE APPLICATION		DOCKET NUMBER DSI 303		APPLICATION NUMBER 10/816,179			
		APPLICANTS Chung J. Lee and Atul Kumar					
		FILING DATE March 31, 2004		GROUP ART UNIT 1763			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FIL. DATE IF APPROP.	
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